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JAO

PATENT
Attorney's Do. No.2522-011

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Yeong-Kwan KIM

Serial No. 09/872,203

Group Art Unit: 2823

Filed: May 31, 2001

Examiner: Julio J. Maldonado

Confirmation No.: 1930

For: METHOD OF FORMING A THIN FILM USING ATOMIC LAYER DEPOSITION

Commissioner for Patents
Washington, D.C. 20231

STATEMENT ON FILING INFORMATION DISCLOSURE STATEMENT
(37 CFR 1.97(e))

I, Alan T. McCollom, the person signing below state that:

each item of information contained in the Information Disclosure Statement submitted herewith was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Statement

Applicant respectfully requests consideration of the accompanying Information Disclosure Statement.

The person making this Statement is the attorney who signs below on the basis of the information in the attorney's file.



20575

PATENT TRADEMARK OFFICE

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.

Alan T. McCollom
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MARGER JOHNSON & McCOLLOM, P.C.
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ON 6-16-03



ATTORNEY DOCKET NO. 2522-011

IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Yeong-Kwan KIM et al.

Serial No.: 09/872,203

Examiner: Julio J. Maldonado

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Title: METHOD OF FORMING A THIN FILM USING ATOMIC LAYER DEPOSITION

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ASSISTANT COMMISSIONER FOR PATENTS
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INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

- ☐ under 37 CFR 1.97 (b), or
(Within three months of filing national application; or date of entry of International application;
or before mailing date of first office action on the merits; whichever occurs last)
- ☒ under 37 CFR 1.97 (c) together with either a:
☒ Statement under 37 CFR 1.97 (e), or
☐ a \$180 fee under 37 CFR 1.17 (p), or
(After mailing of first Office Action, but prior to Notice of Allowance or Final Office Action)
- ☐ under 37 CFR 1.97 (d) together with:
☐ Statement under 37 CFR 1.97 (e), or
☐ a \$180.00 fee set forth in 37 CFR 1.17 (p).
(Filed after final action or notice of allowance, whichever occurs first, but before payment of

the issue fee)

☒ Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation together with copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

It is requested that the information disclosed herein be made of record in this application.

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703. A duplicate copy of this sheet is enclosed.



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PATENT TRADEMARK OFFICE

Respectfully submitted,

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ON 1-16-03